

Indexed in: PubMed



an Open Access Journal by MDPI

### **Multi-Dimensional Direct-Write Nanofabrication**

Guest Editor:

#### Dr. Harald Plank

Institute of Electron Microscopy and Nanoanalysis, Graz University of Technology, Steyrergasse 17, 8010 Graz, Austria

Deadline for manuscript submissions:

closed (31 October 2019)

## Message from the Guest Editor

Dear Colleagues,

During the last decade, additive direct-write manufacturing has attracted considerable attention in research and development. The main advantage of such a method is the ability to fabricate complex structures in a single-step, which expands accessibility to non-flat morphologically exposed areas, already finished device architectures, or encapsulated packages; accordingly, such direct-write technologies complement situations in which alternative methods approach their intrinsic limitations. While applications on the micro- and meso-scale below are already well established in industrial productions such as roll-to-roll processes, laser sintering, inkjet printing, or imprint lithography, the extension to the real nanoscale is still an ongoing and highly challenging task. Promising candidates with the potential to meet these dimensional requirements are photons, ions, or electrons, demonstrated by numerous proof-of-principle studies during the last decade. Aside from their technical nature, direct-write approaches enable controlled fabrication of complex, freestanding 3D nano-architectures in a single step, which paves the way for novel applications.













an Open Access Journal by MDPI

## **Editor-in-Chief**

# **Message from the Editor-in-Chief**

You are invited to contribute research articles or comprehensive reviews for consideration and publication in *Micromachines* (ISSN 2072-666X). *Micromachines* is published in the open access format. Research articles, reviews and other contents are released on the internet immediately after acceptance. The scientific community and the general public have unlimited free access to the content as soon as it is published. As an open access journal, *Micromachines* is supported by the authors or their institutes by payment of article processing charges (APC) for accepted papers. We are pleased to welcome you as our authors.

### **Author Benefits**

**Open Access:** free for readers, with article processing charges (APC) paid by authors or their institutions.

**High Visibility:** indexed within Scopus, SCIE (Web of Science), PubMed,

PMC, Ei Compendex, dblp, and other databases.

Journal Rank: JCR - Q2 (*Chemistry, Analytical*) / CiteScore - Q2 (*Mechanical* 

Engineering)

#### **Contact Us**